

FIG.1 A

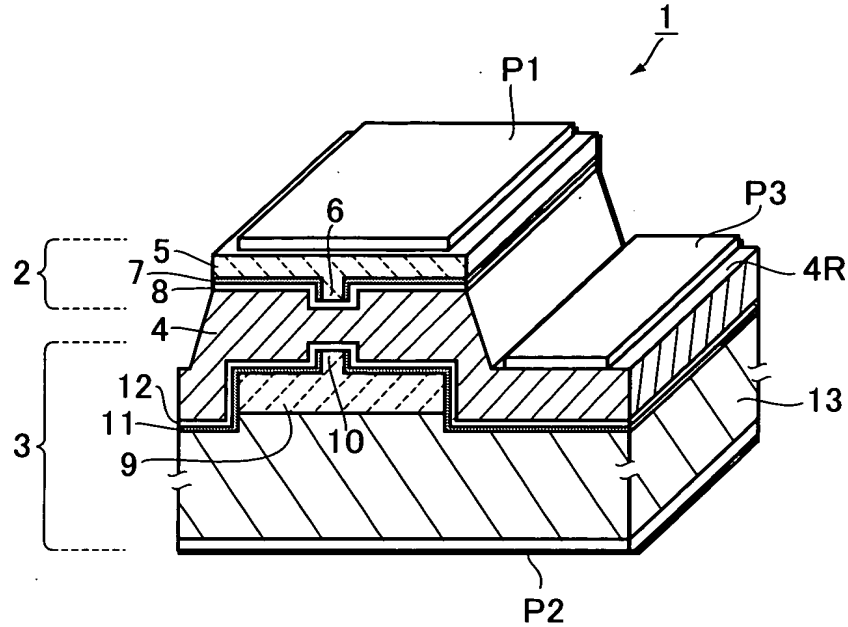


FIG.1 B

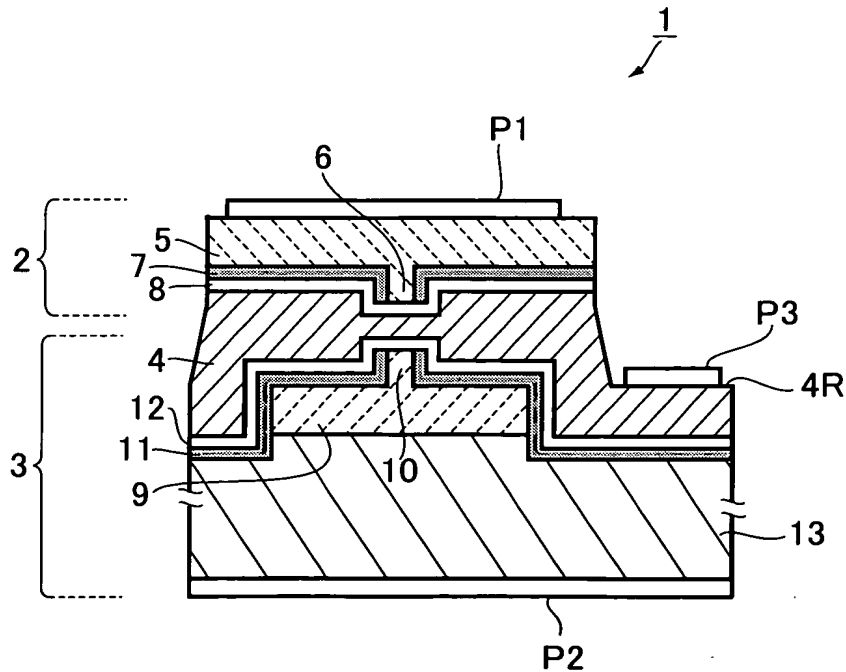


FIG.2 A

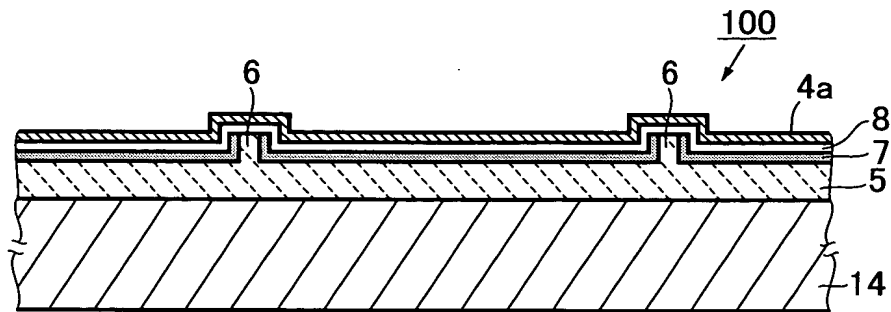


FIG.2 B

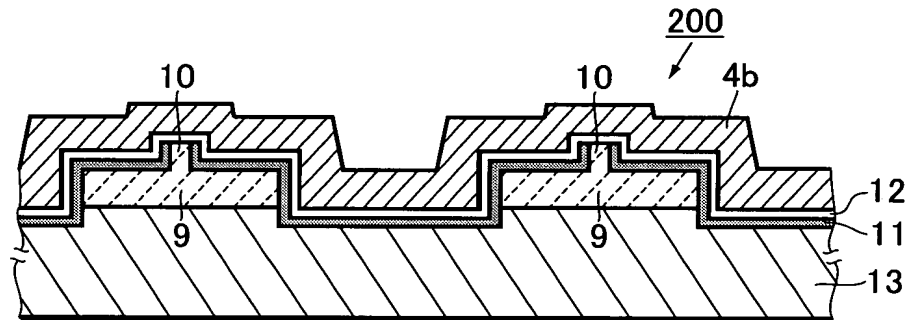
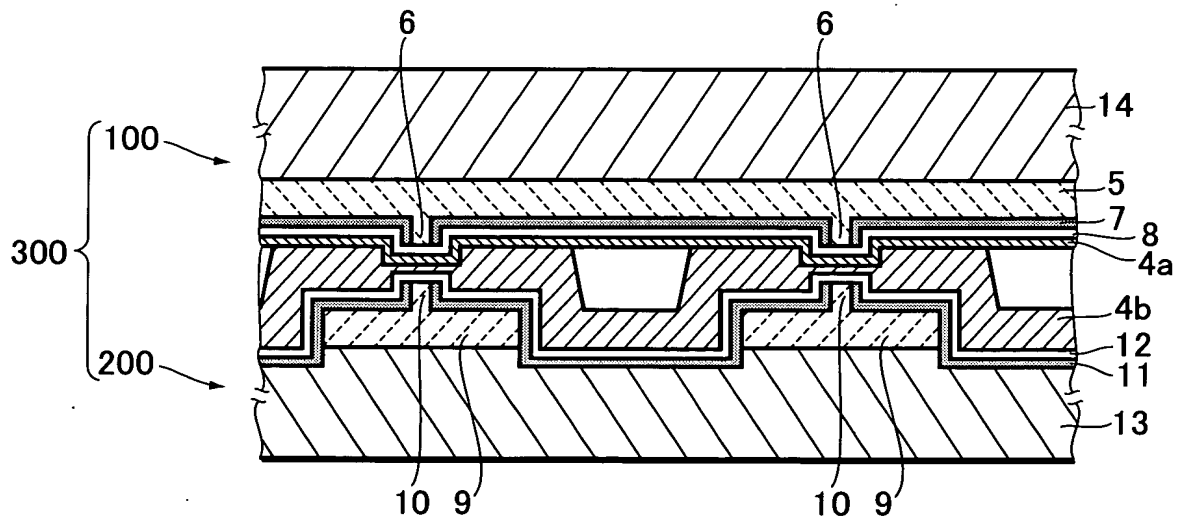


FIG.2 C



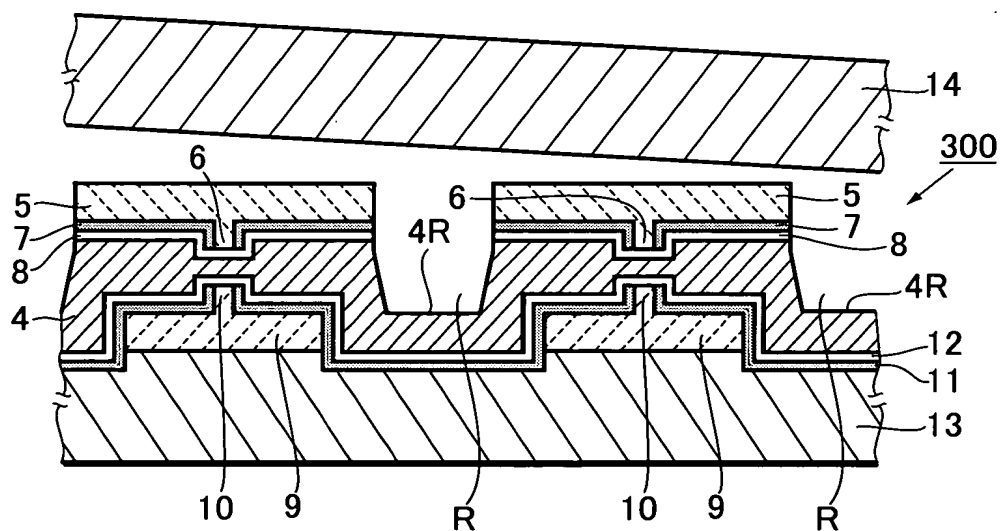


FIG.4 A

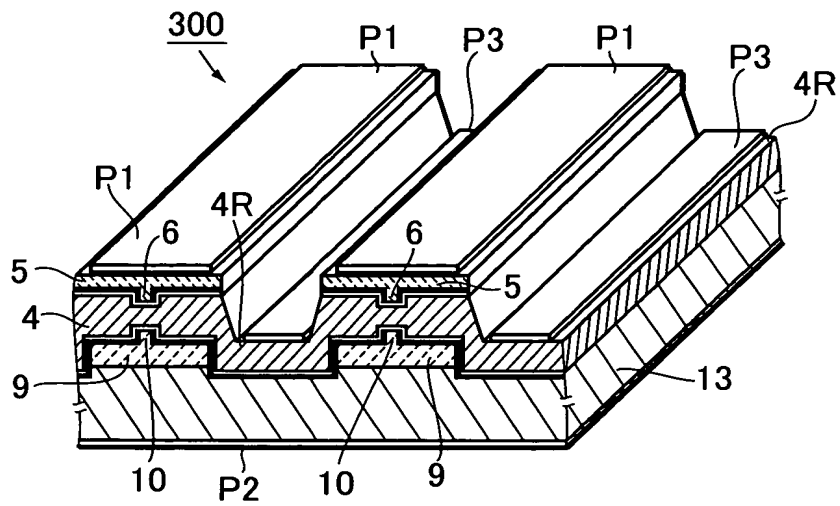


FIG.4 B

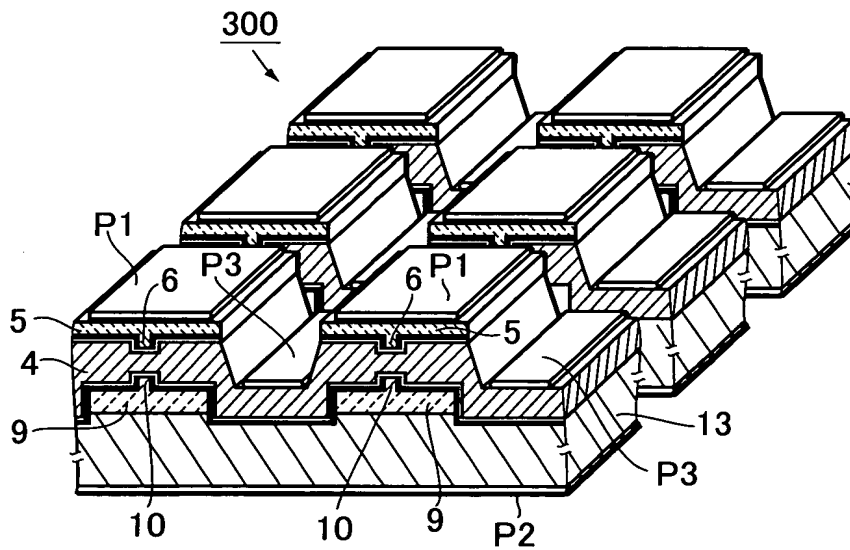


FIG.4 C

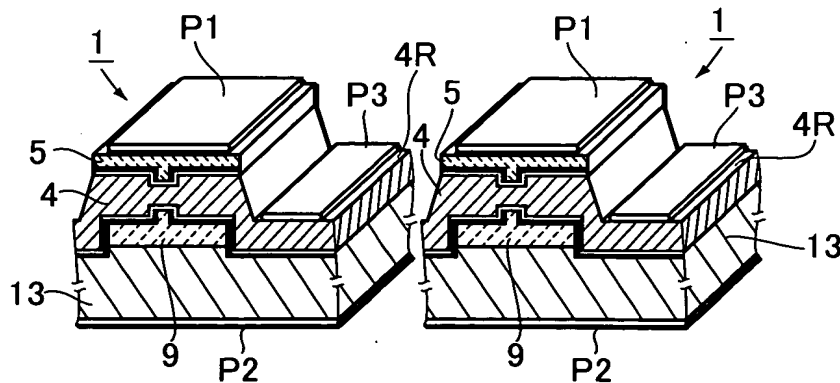
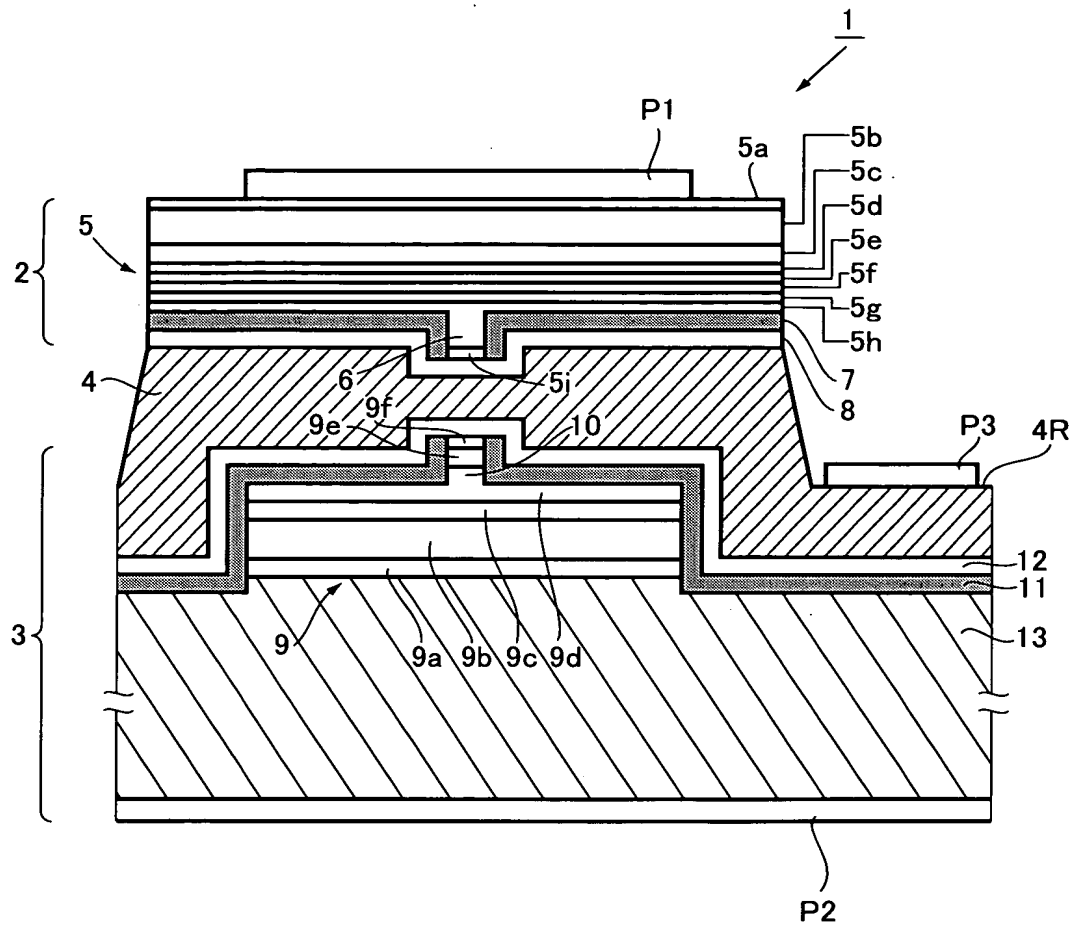


FIG.5



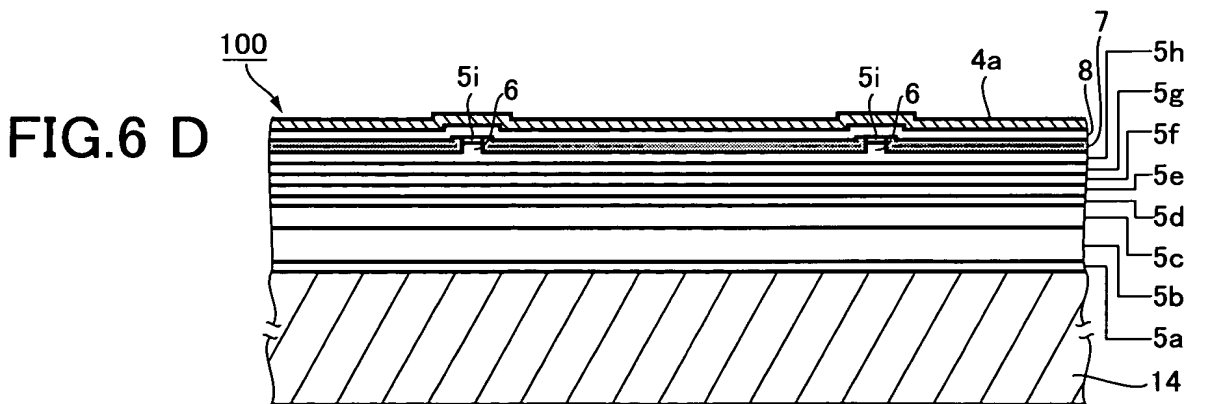
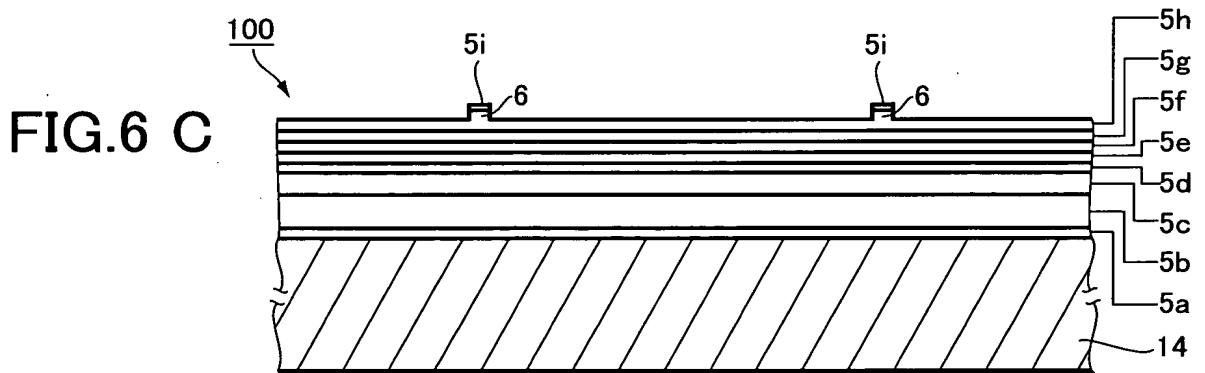
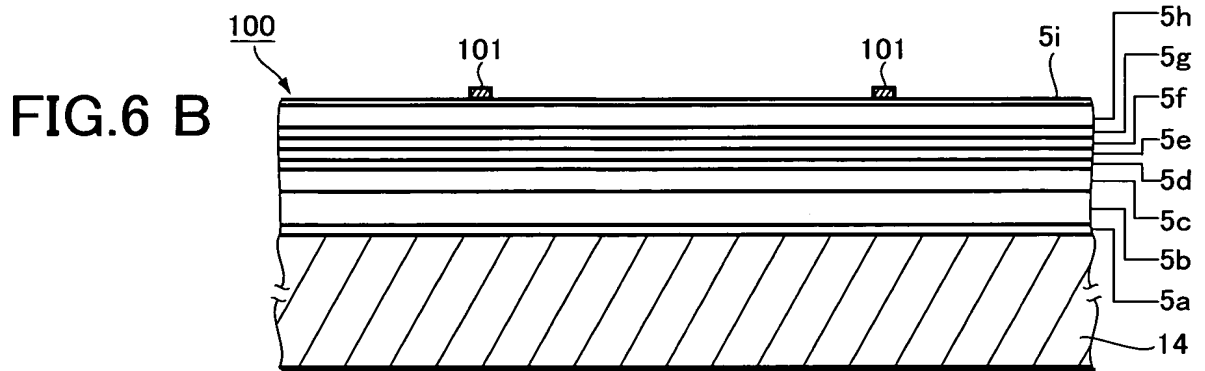
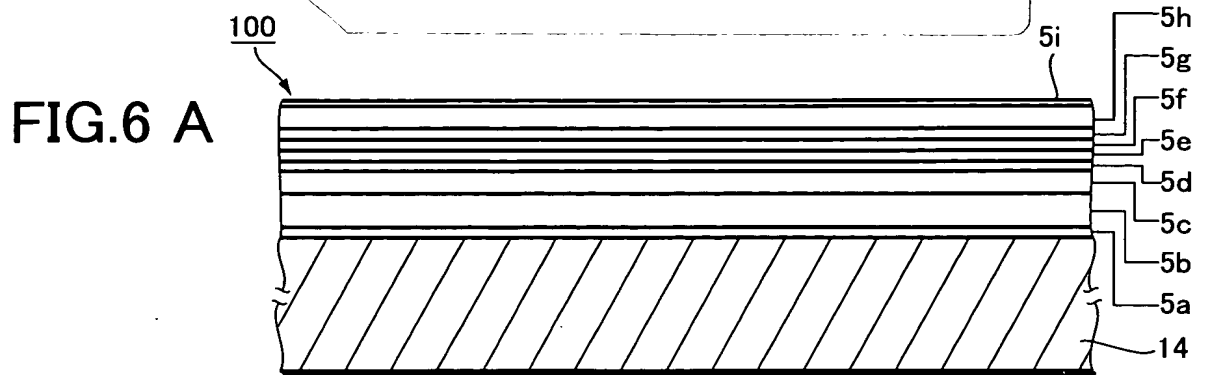


FIG.7 A

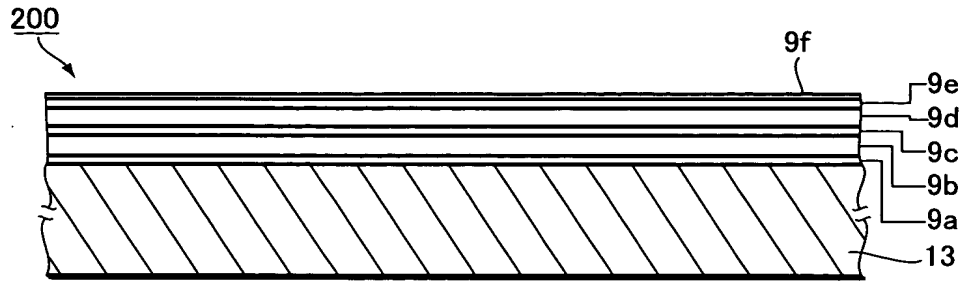


FIG.7 B

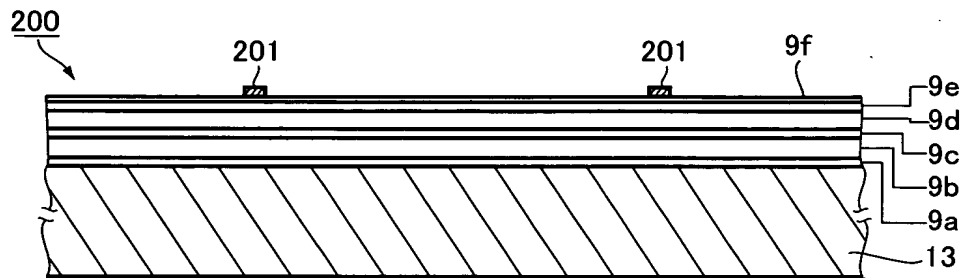


FIG.7 C

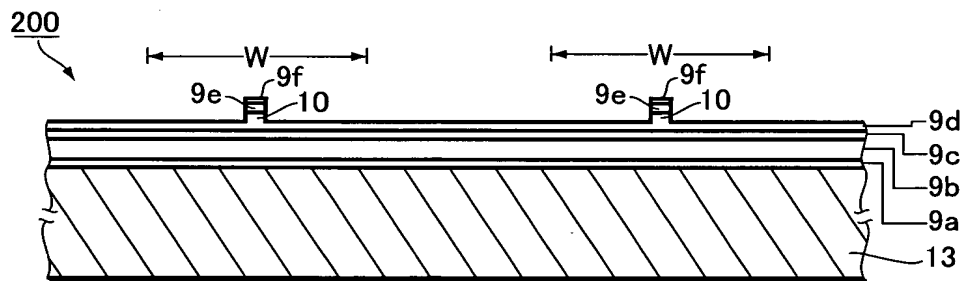


FIG.7 D

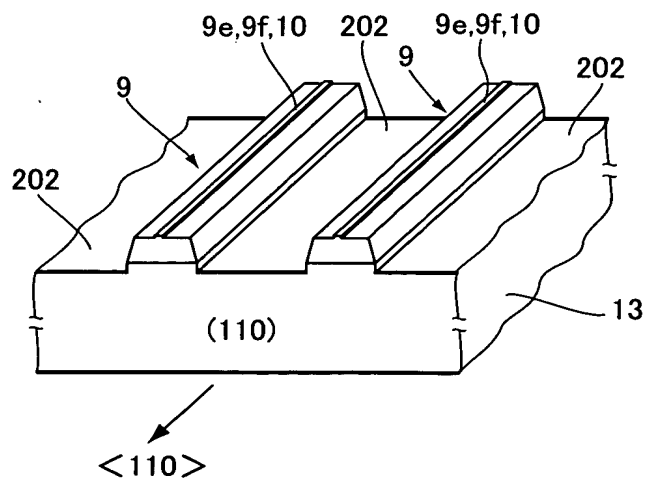


FIG.8 A

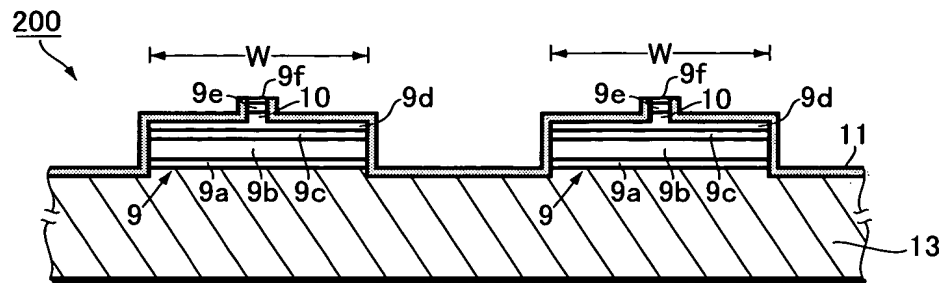


FIG.8 B

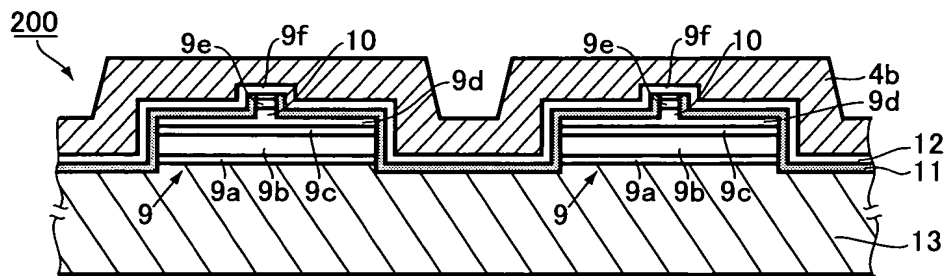


FIG.9

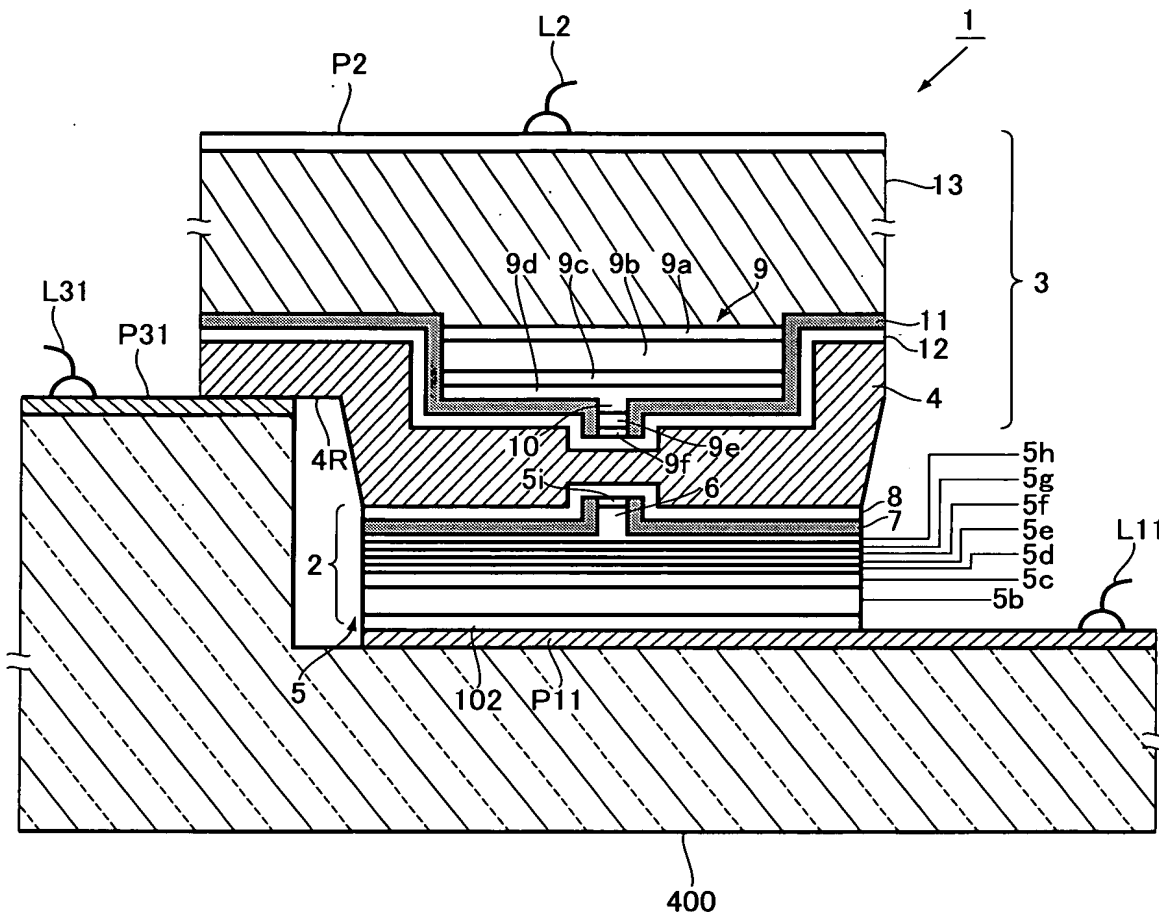


FIG.10 A

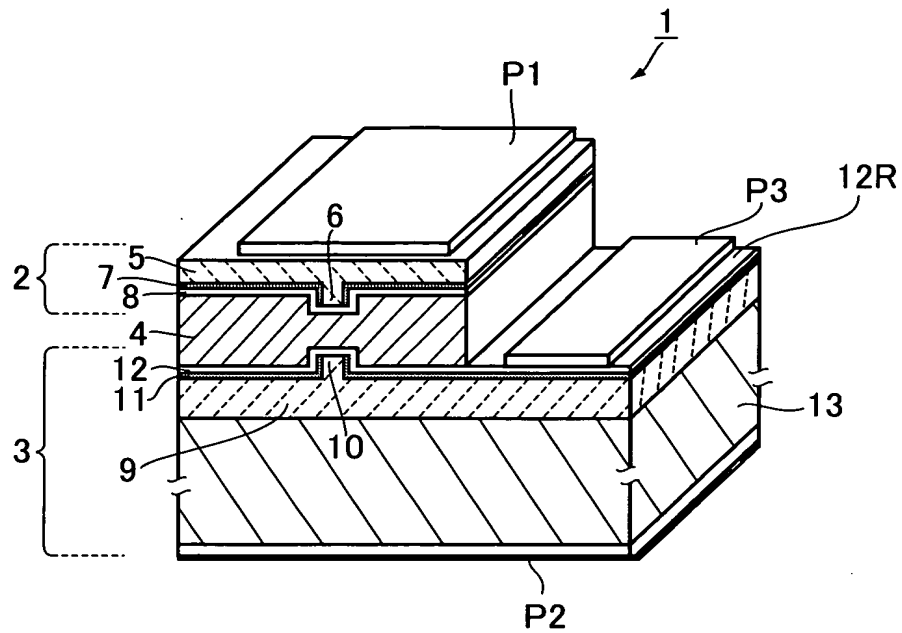


FIG.10 B

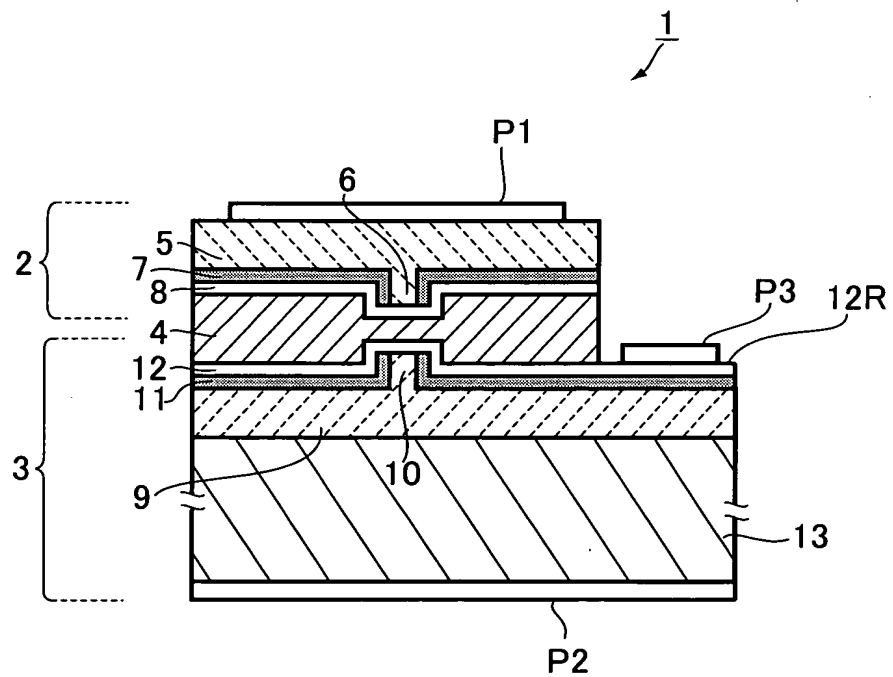


FIG.11 A

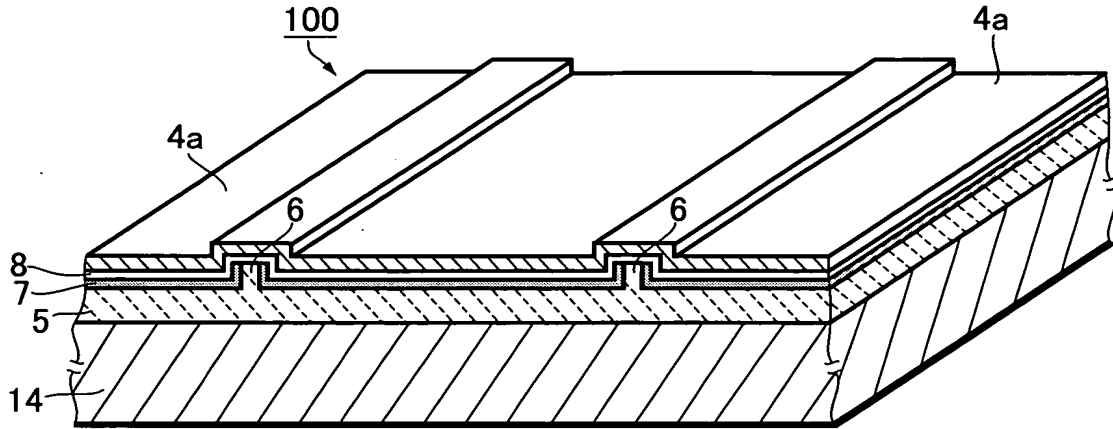


FIG.11 B

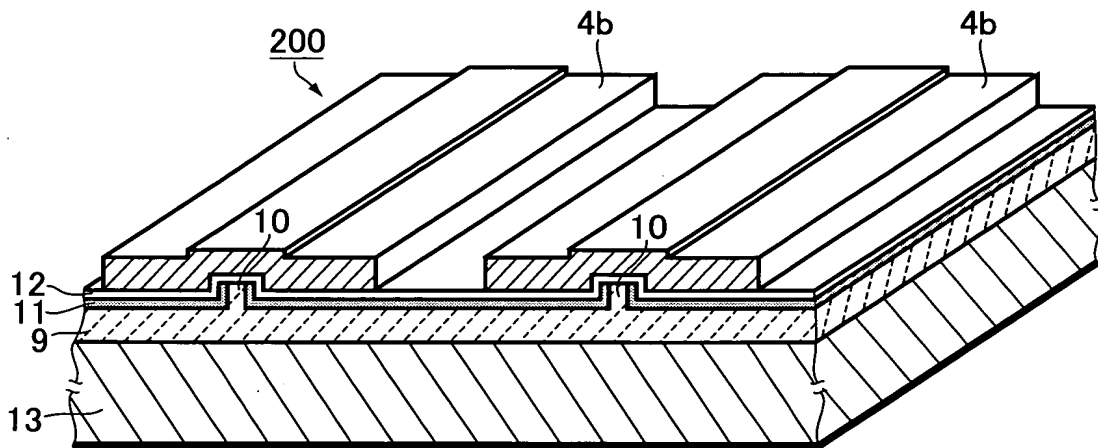


FIG.12 A

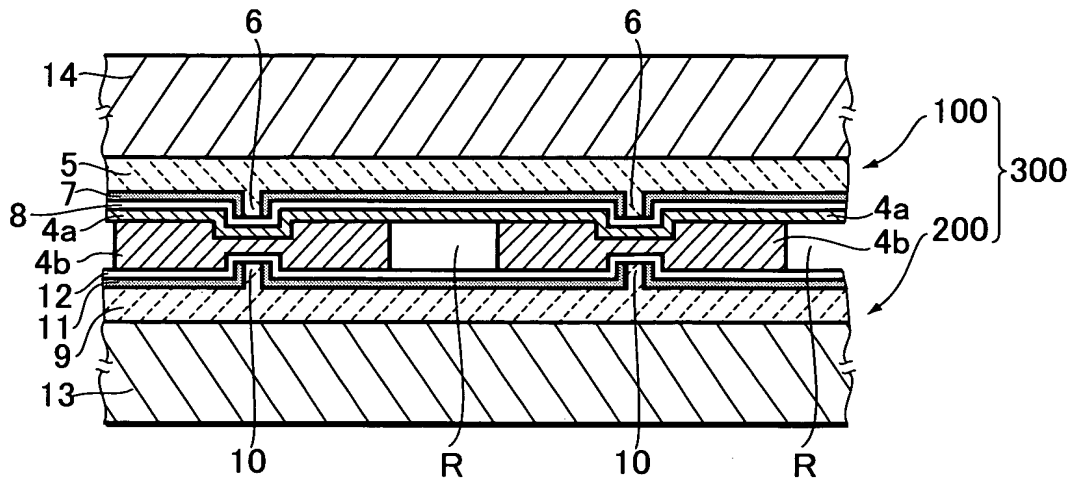


FIG.12 B

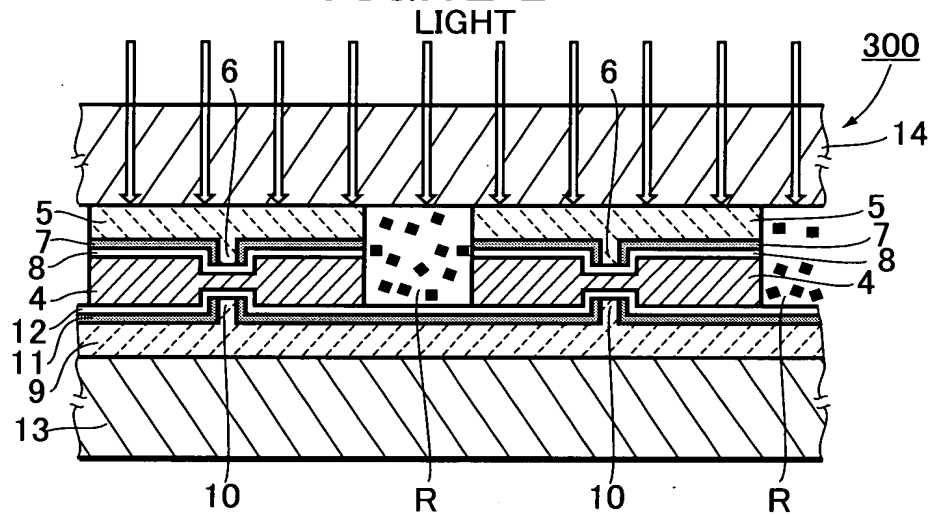
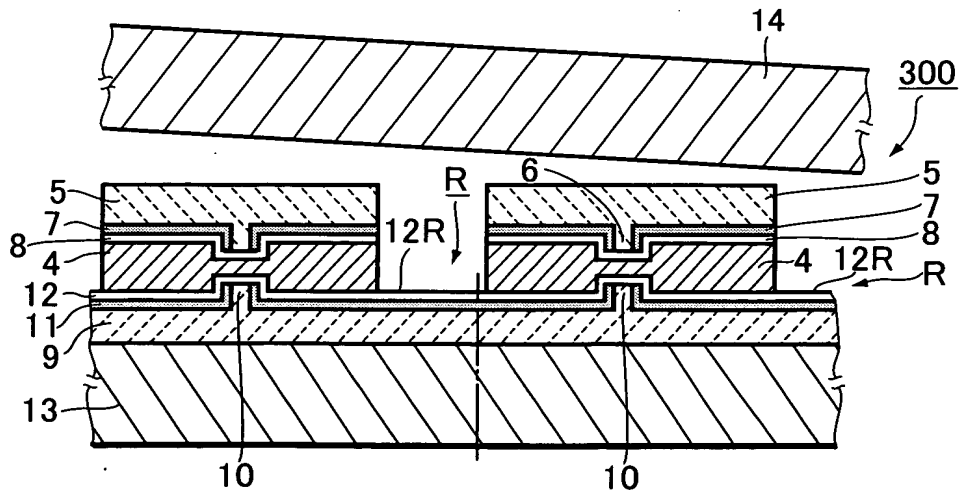


FIG.12 C



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FIG.13

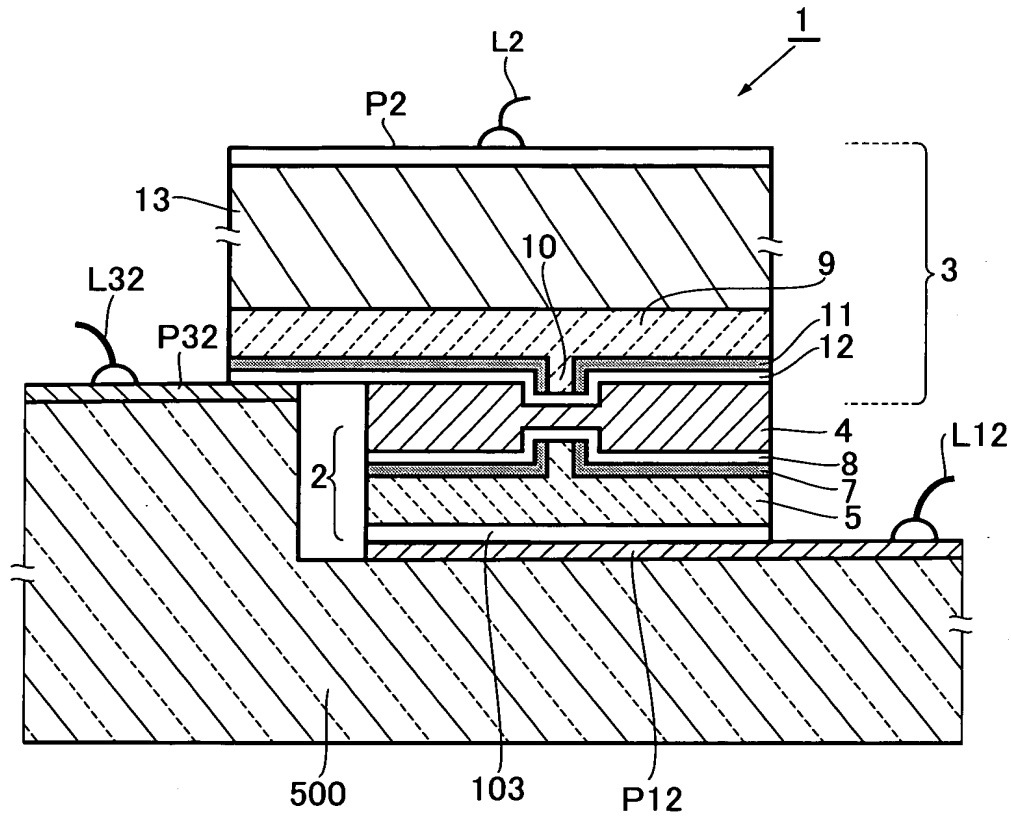


FIG.14 A

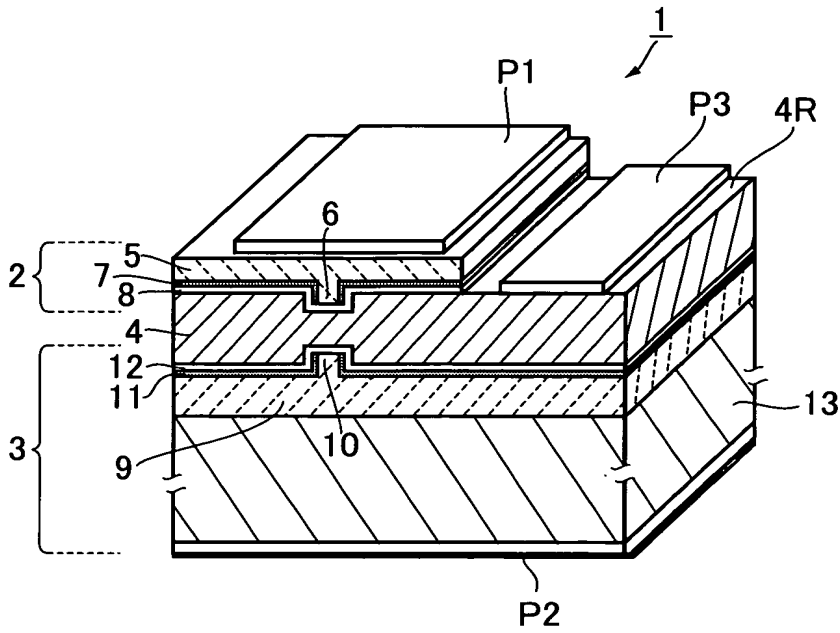


FIG.14 B

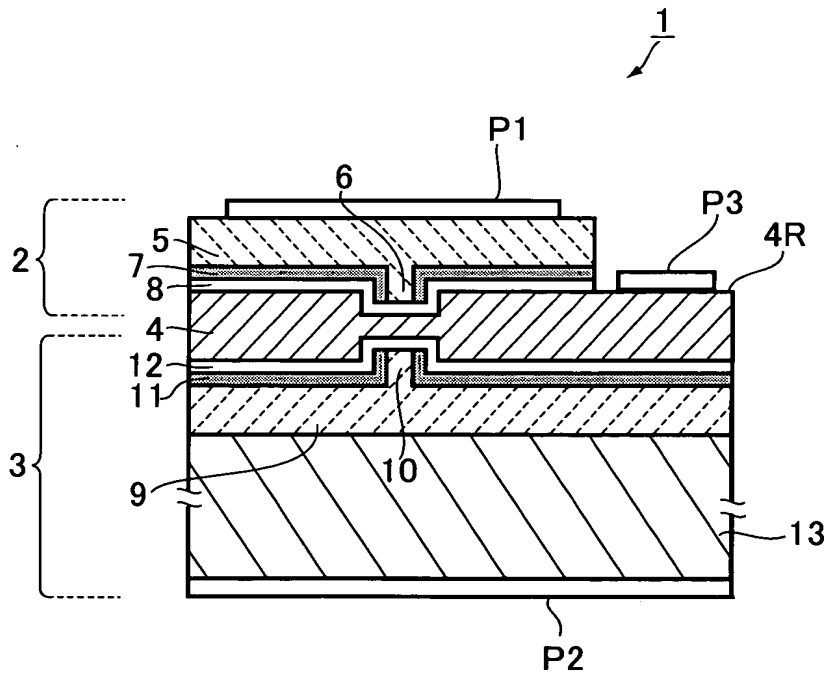


FIG.15 A

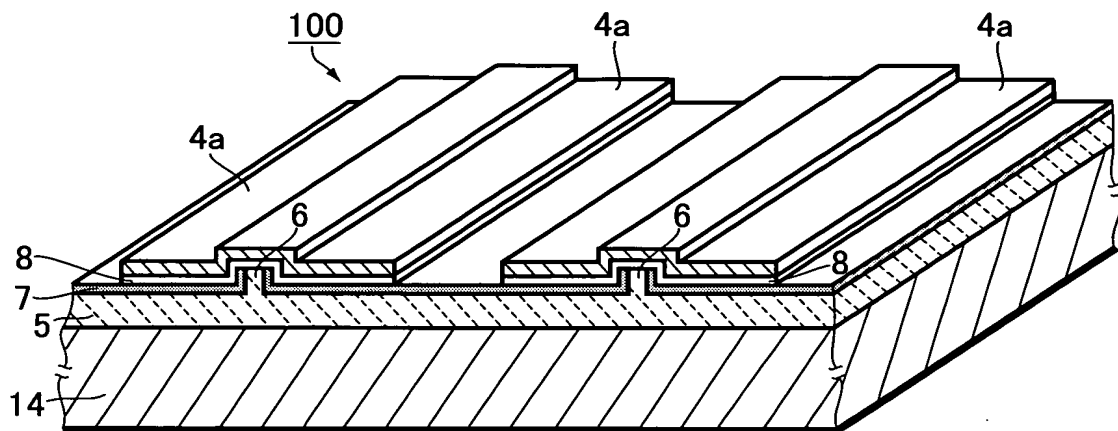


FIG.15 B

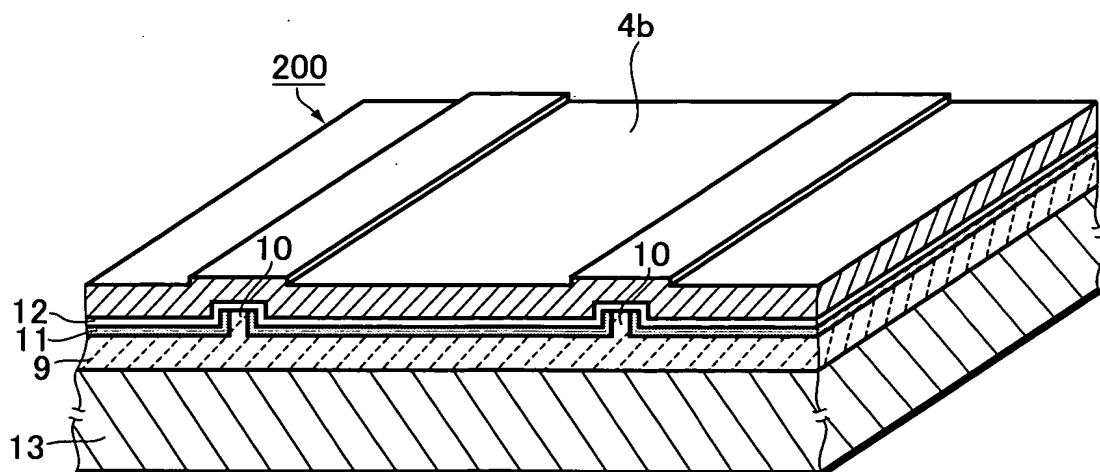


FIG.16 A

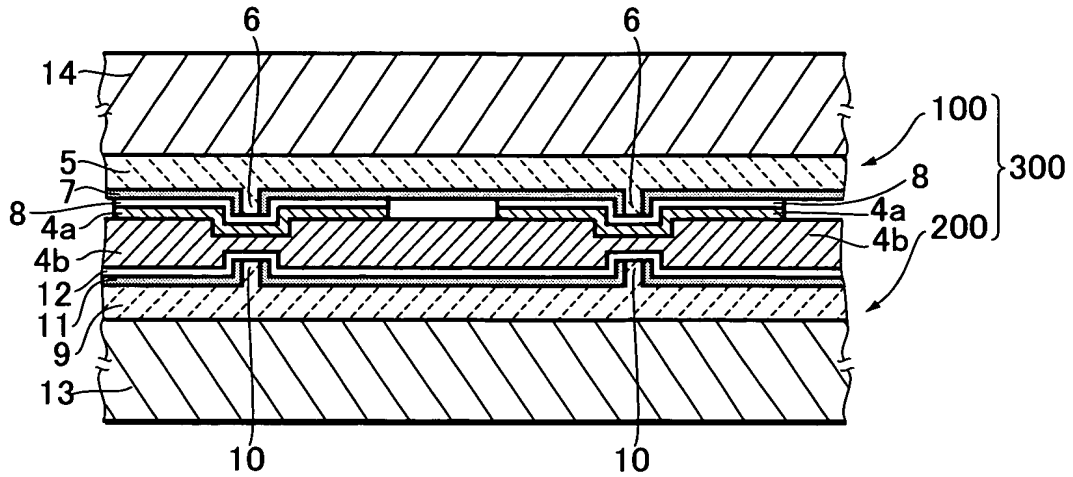


FIG.16 B

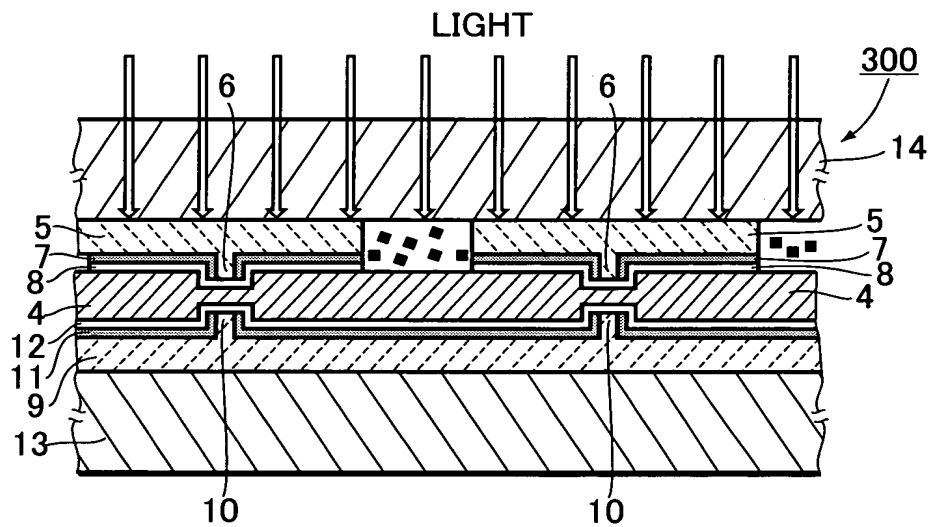


FIG.16 C

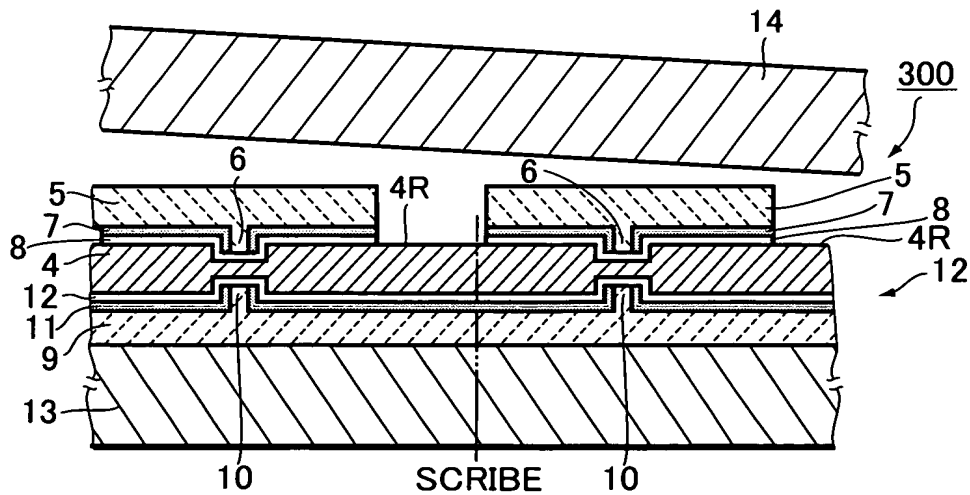
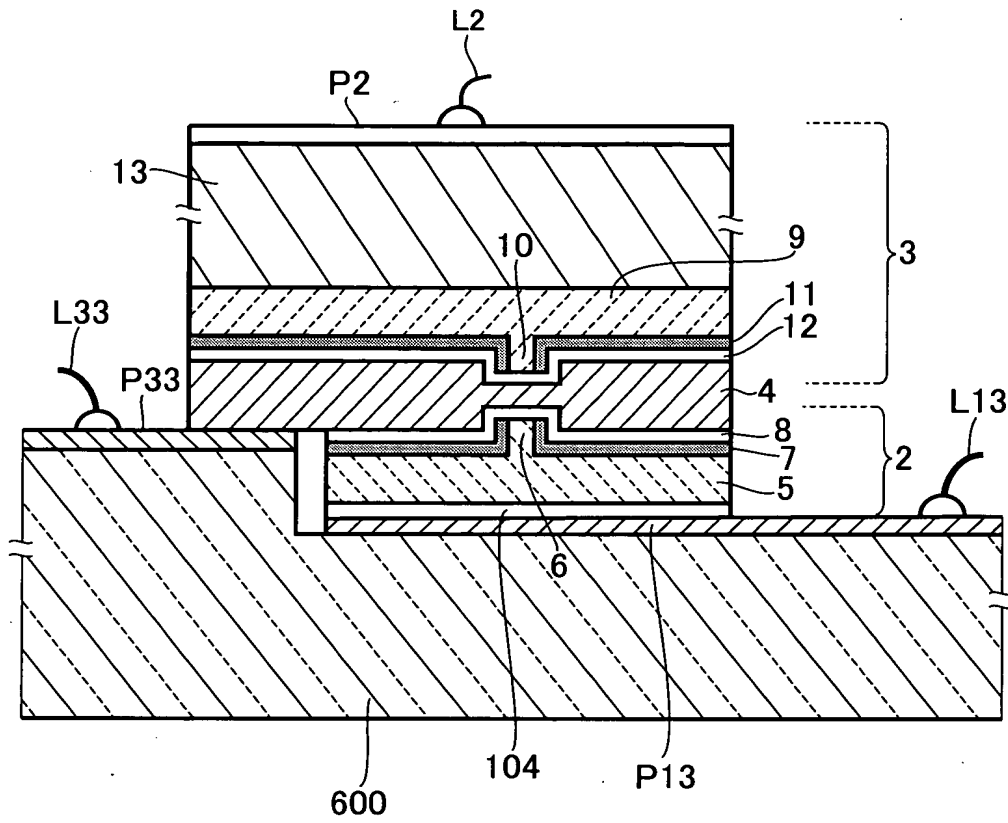


FIG.17



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Application No.: New Application
Docket No.: 107156-00217

FIG. 18

